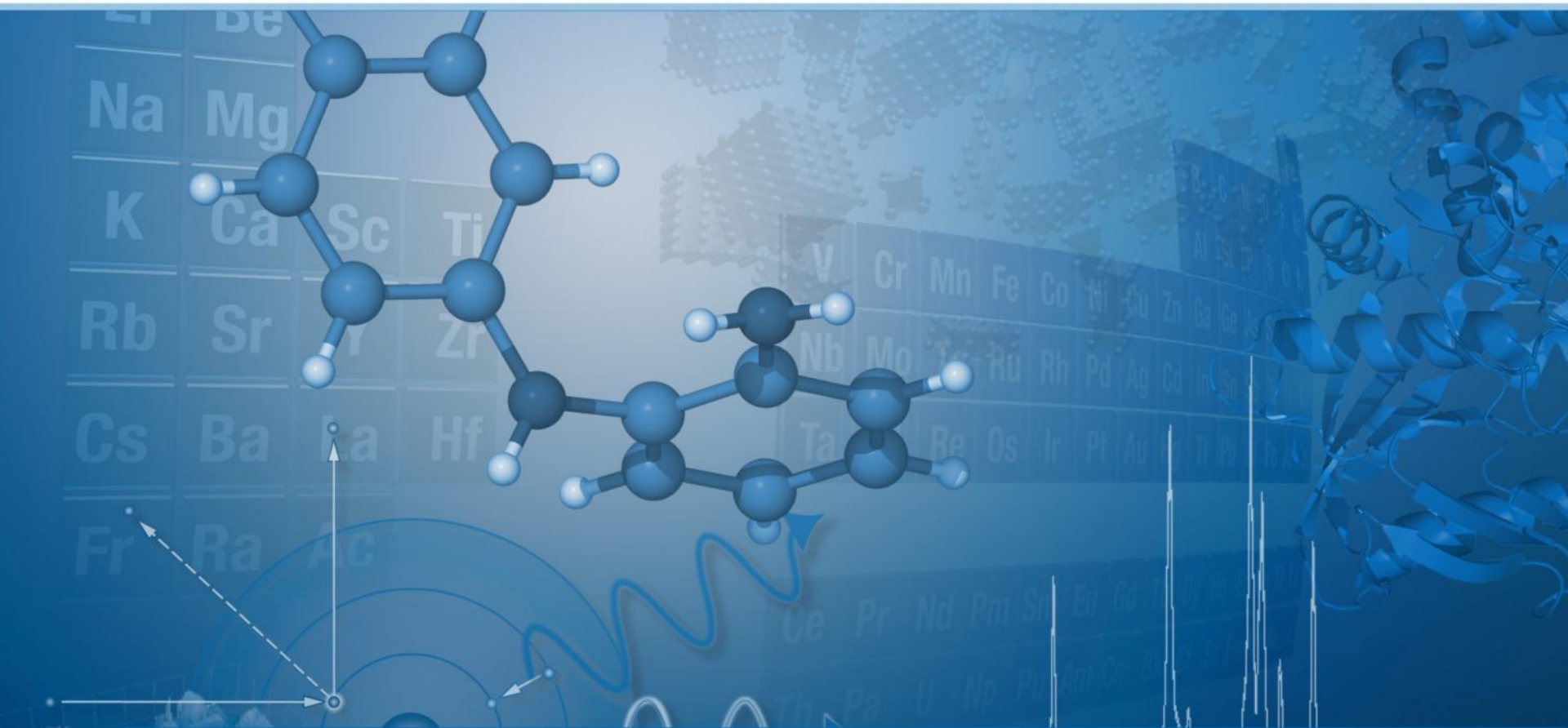


Developments in detector technology for XRD



Roger Durst

Bruker AXS Inc.

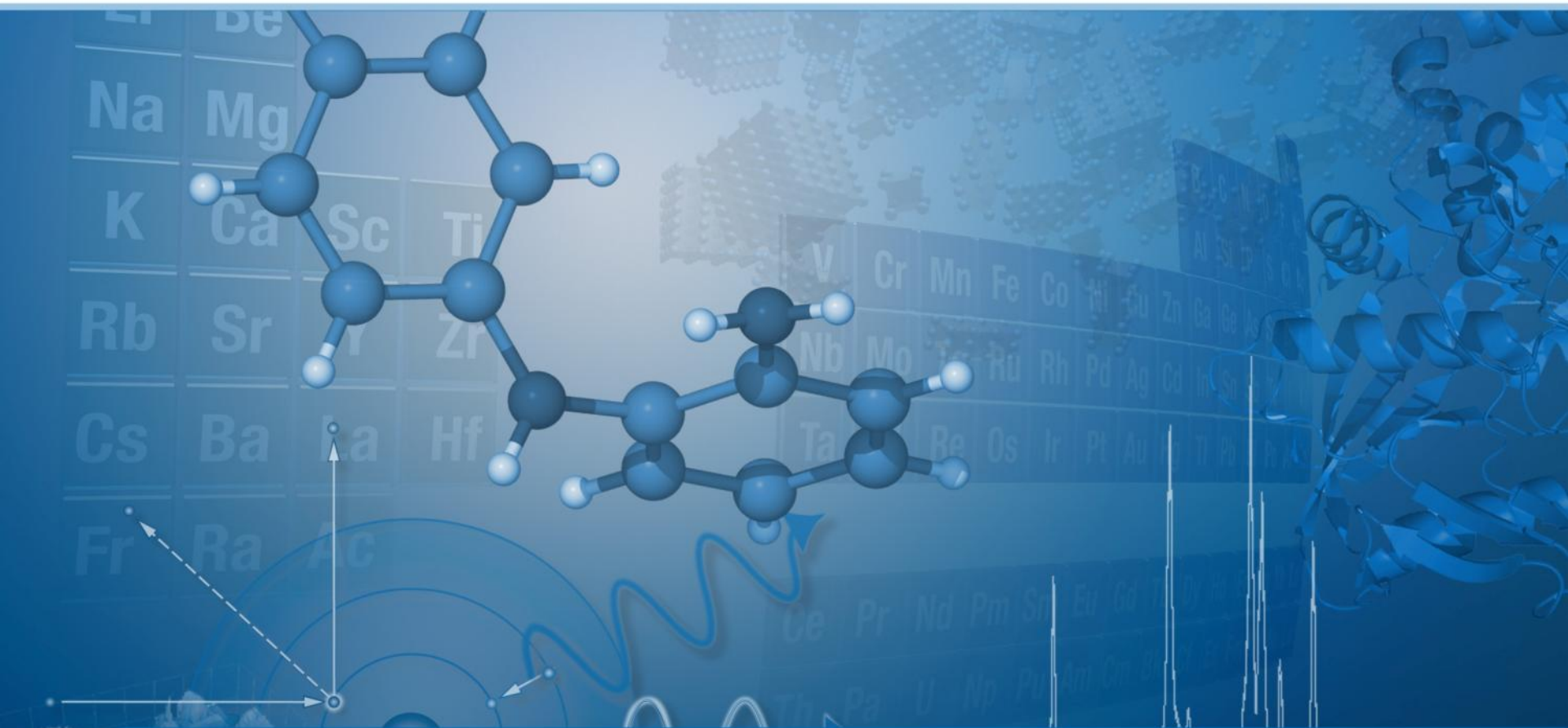


Detector technology for enhanced speed and accuracy



- *Energy discriminating strip detectors*
- *2D detectors*

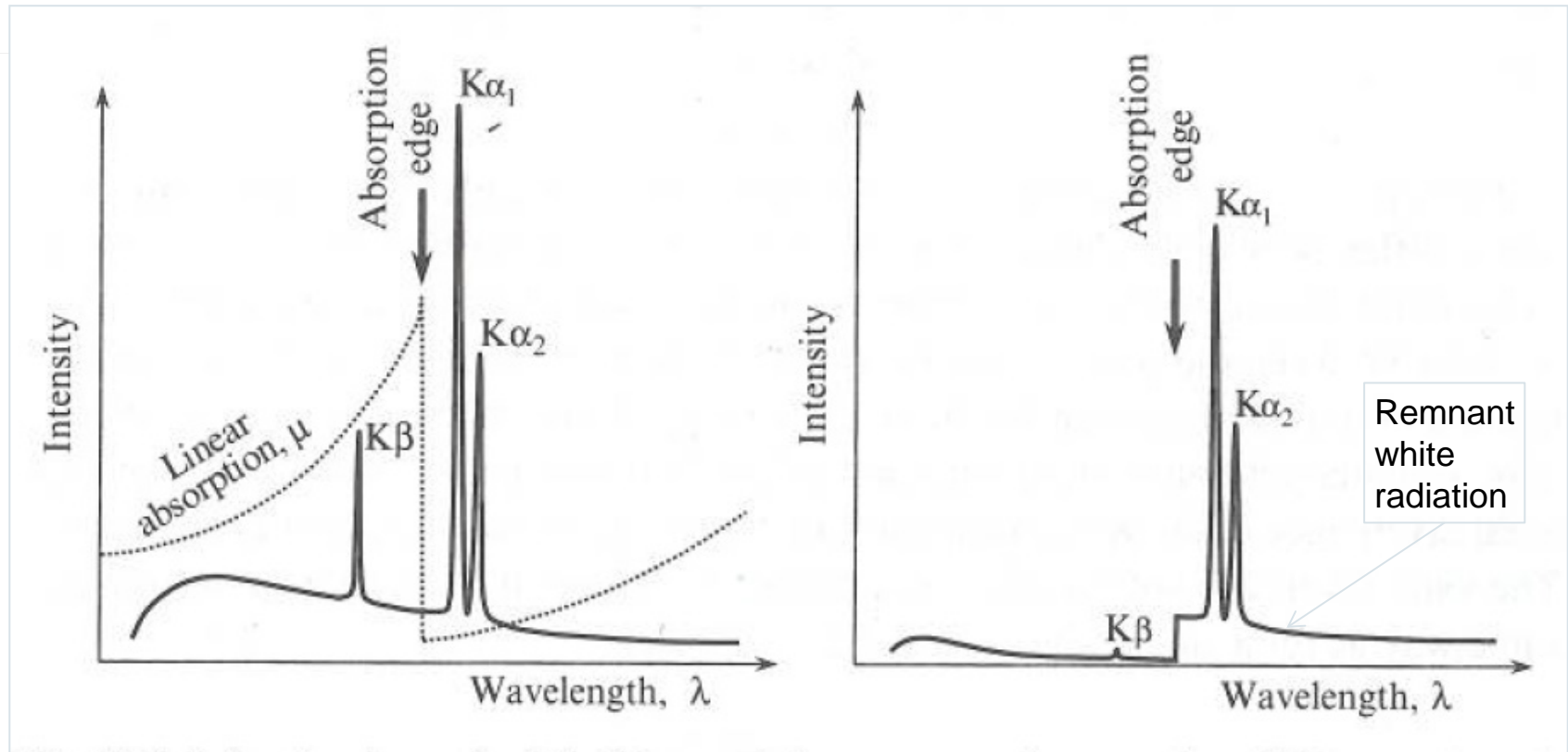
Monochromatization and energy dispersive detectors



Monochromatization

- Before 2000, >90% of all instruments have been equipped with point detectors, > 50% with (secondary) monochromators
 - Intensity loss ~80-90% with respect to unfiltered rad.
- Today, >90% of all instruments are equipped with PSDs, the majority with K β -Filters
 - Intensity loss ~40-60% with respect to unfiltered radiation
 - Absorption edges
 - Poor filtering of fluorescence
- ***An energy dispersive detector could in principle improve effective sensitivity by 2-10 times and reduce errors due to absorption edges and fluorescence***

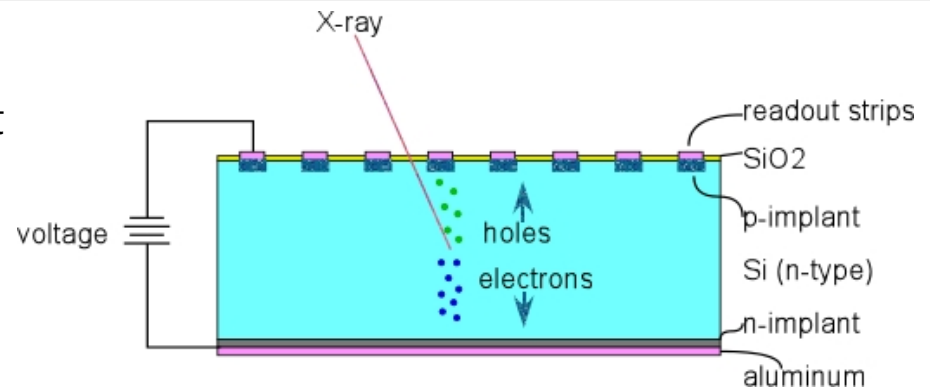
Monochromatization Artifacts from K β -Filter



Pecharsky & Zavalij (2009)

Silicon strip detector principle

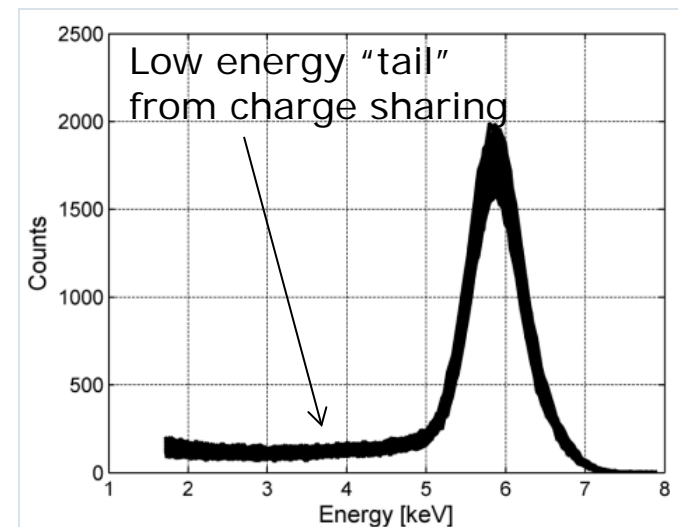
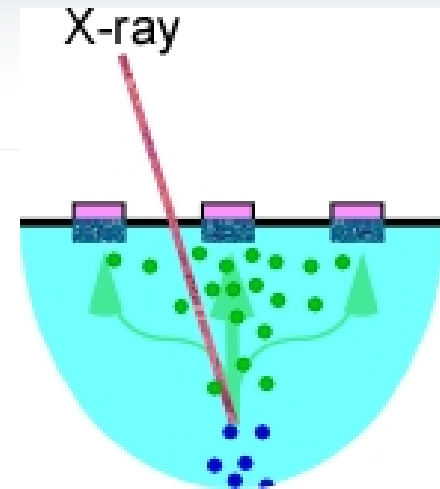
- Electron-hole pairs created in depleted silicon by X-ray photoionization
 - Charge carriers drift to readout strips
- Key advantages
 - High counting rate
 - Typically of order 10^6 counts/strip-sec
 - Good spatial resolution
 - Good energy resolution than other detectors
 - Requires optimized readout



Limitations of energy resolution due to charge sharing effects



- Energy resolution is accomplished by "counting" the electrons in a strip or pixel
 - $\Delta E \geq 2.35 \sqrt{\frac{F}{N}}$
 - F =Fano factor, N =# of electron-hole pairs
- Problem, ***not all electrons are collected in a given strip (or pixel)***, in general some electrons will diffuse to neighboring strips or pixels: "charge sharing"
 - Fall below discriminator level and are thus "lost"
 - Lost electrons cause poor energy resolution



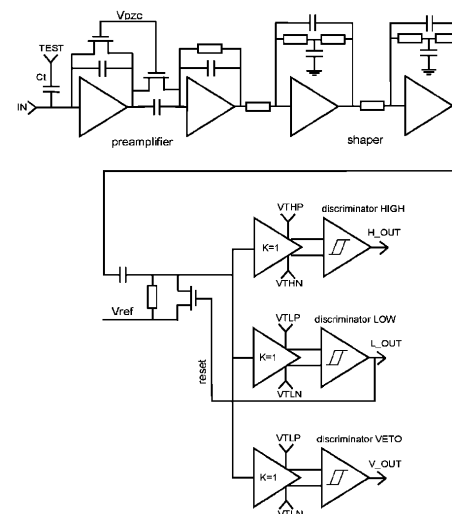
LYNXEYE XE



- The LYNXEYE XE is the first **energy dispersive Si strip detector** for home-laboratory X-ray diffraction
 - Inter-strip logic to correct for charge sharing

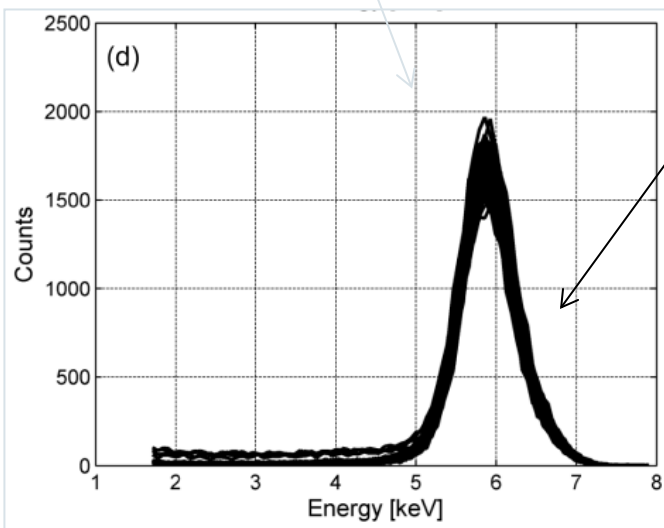
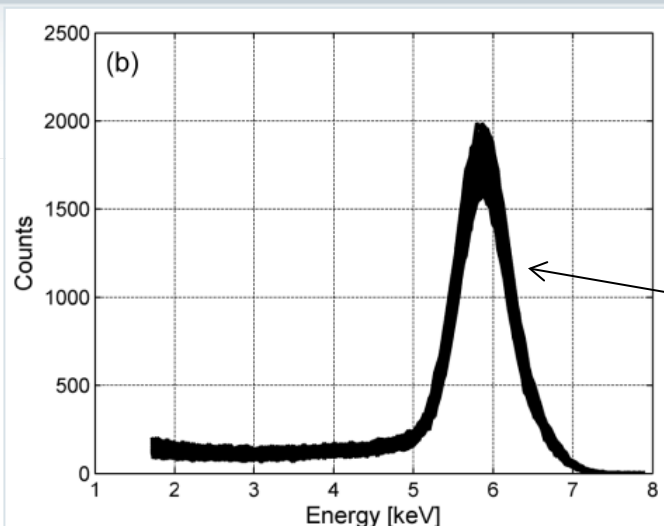


Detector type	Compound silicon strip
# strips	192 strips, 75 mm pitch
Active area	14.4 x 16mm
Modes	1D and 0D
Wavelengths	Cr, Co, Cu, Mo, and Ag
Energy resolution (Cu)	< 680 eV @ 8 KeV



LYNXEYE XE

Energy Resolution with inter-strip logic

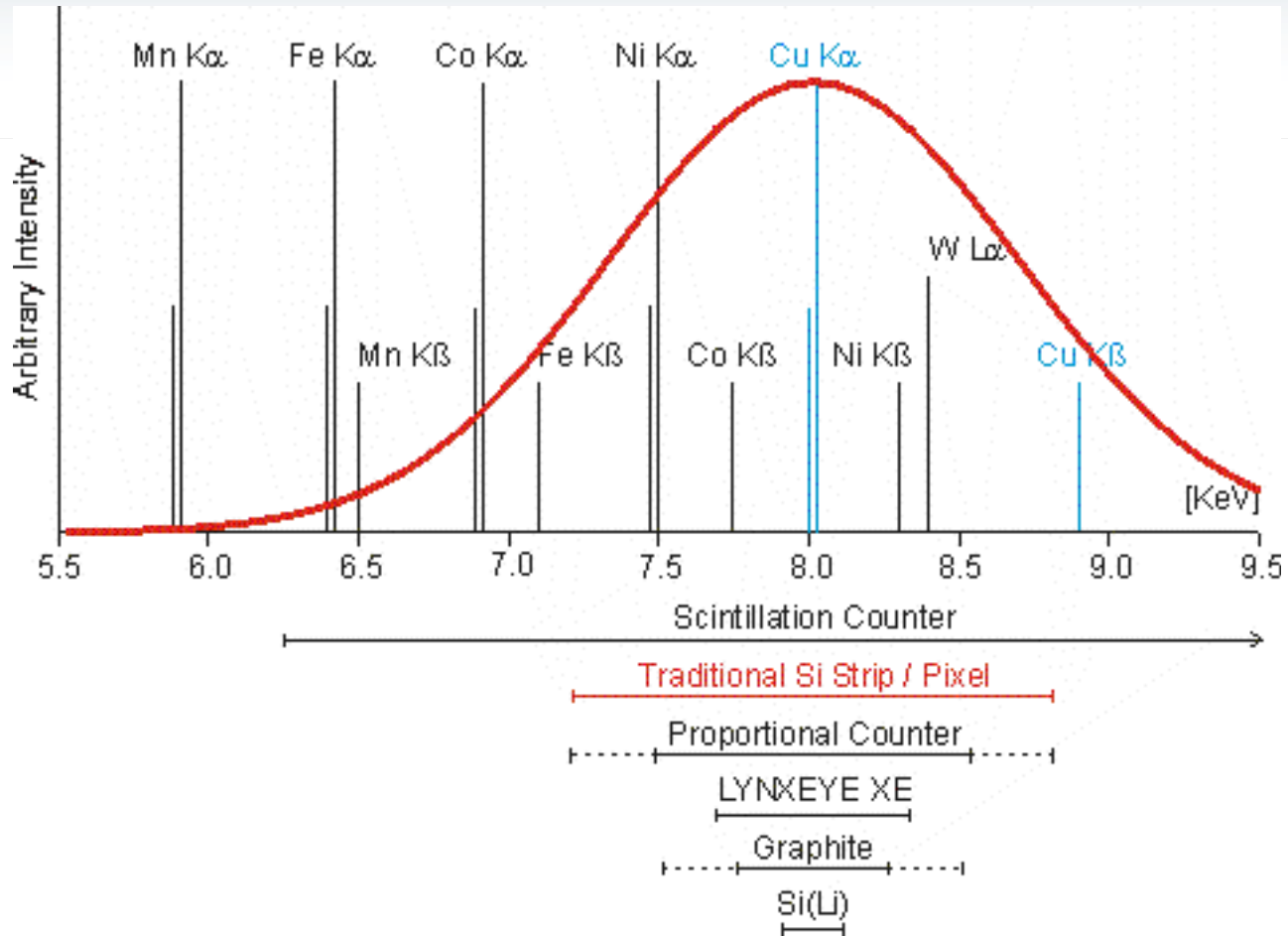


Device	Resolution (KeV)
Scintillation counter	~3.5
Traditional silicon strip / pixel	~1.6 - 2.0
Proportional counter	~1.1 - 1.6
LYNXEYE XE	<0.68
Graphite monochromator	~0.5 - 1.0
Si(Li) detector (Peltier cooled)	<0.2

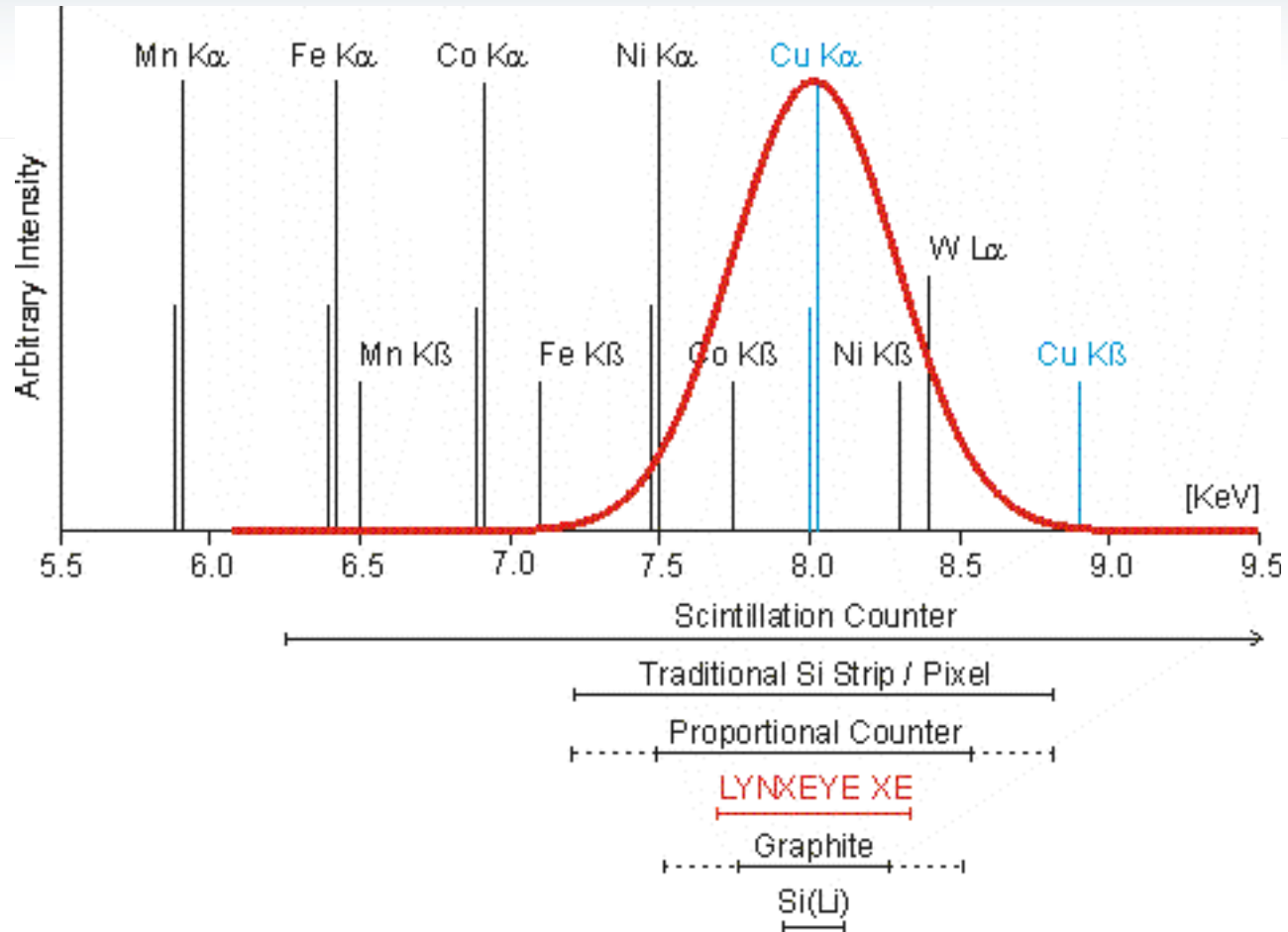
Incorporation in inter-strip logic improves energy resolution 2-3 times compared to conventional Si detector

Comparable to Graphite monochromator

Monochromatization Traditional Si Strip



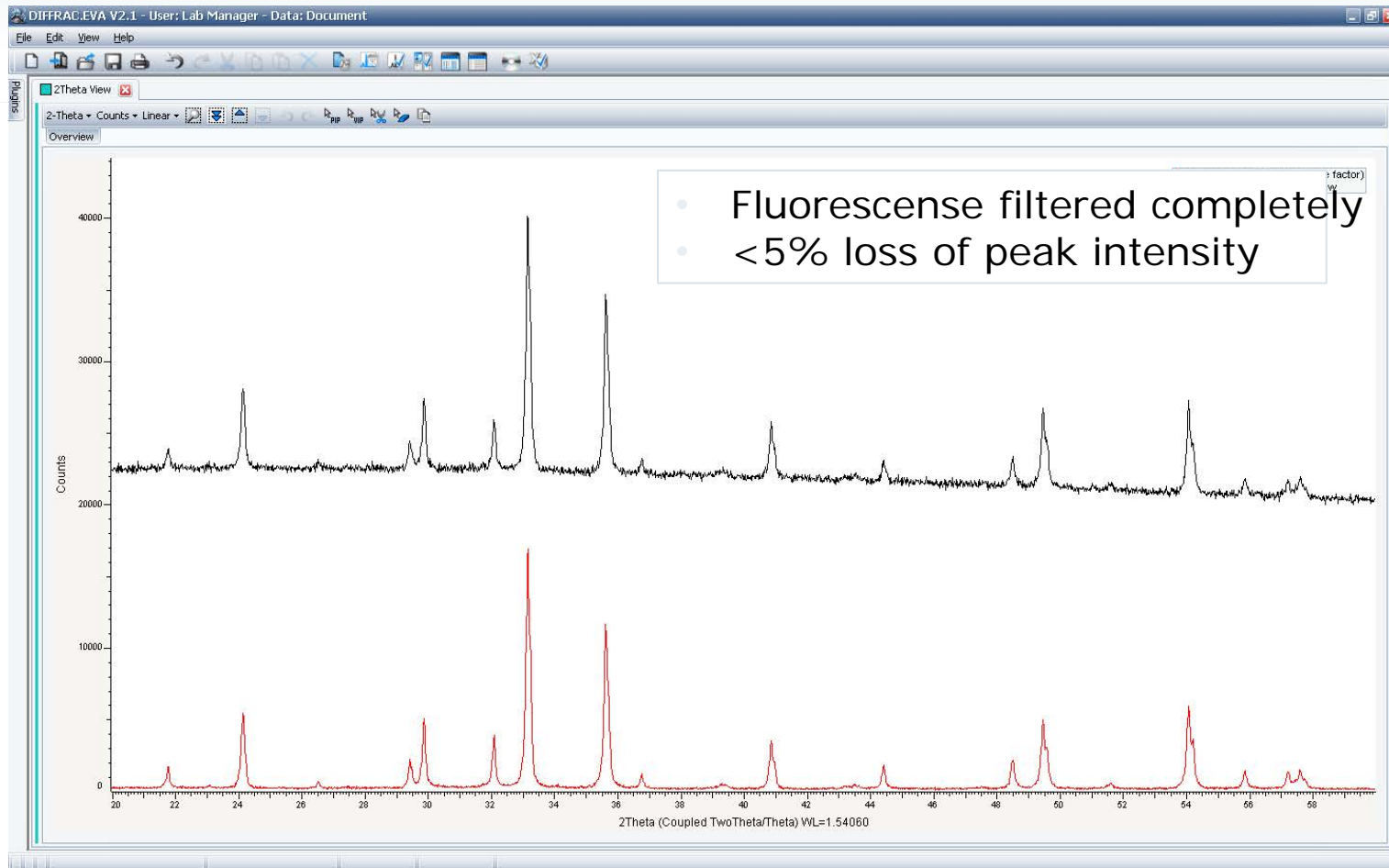
Monochromatization LYNXEYE XE



Filtering of fluorescence radiation (Cu)

LYNXEYE XE

Filtering Fe fluorescence: Iron Ore



Filtering of Fluorescence Radiation (Cu)

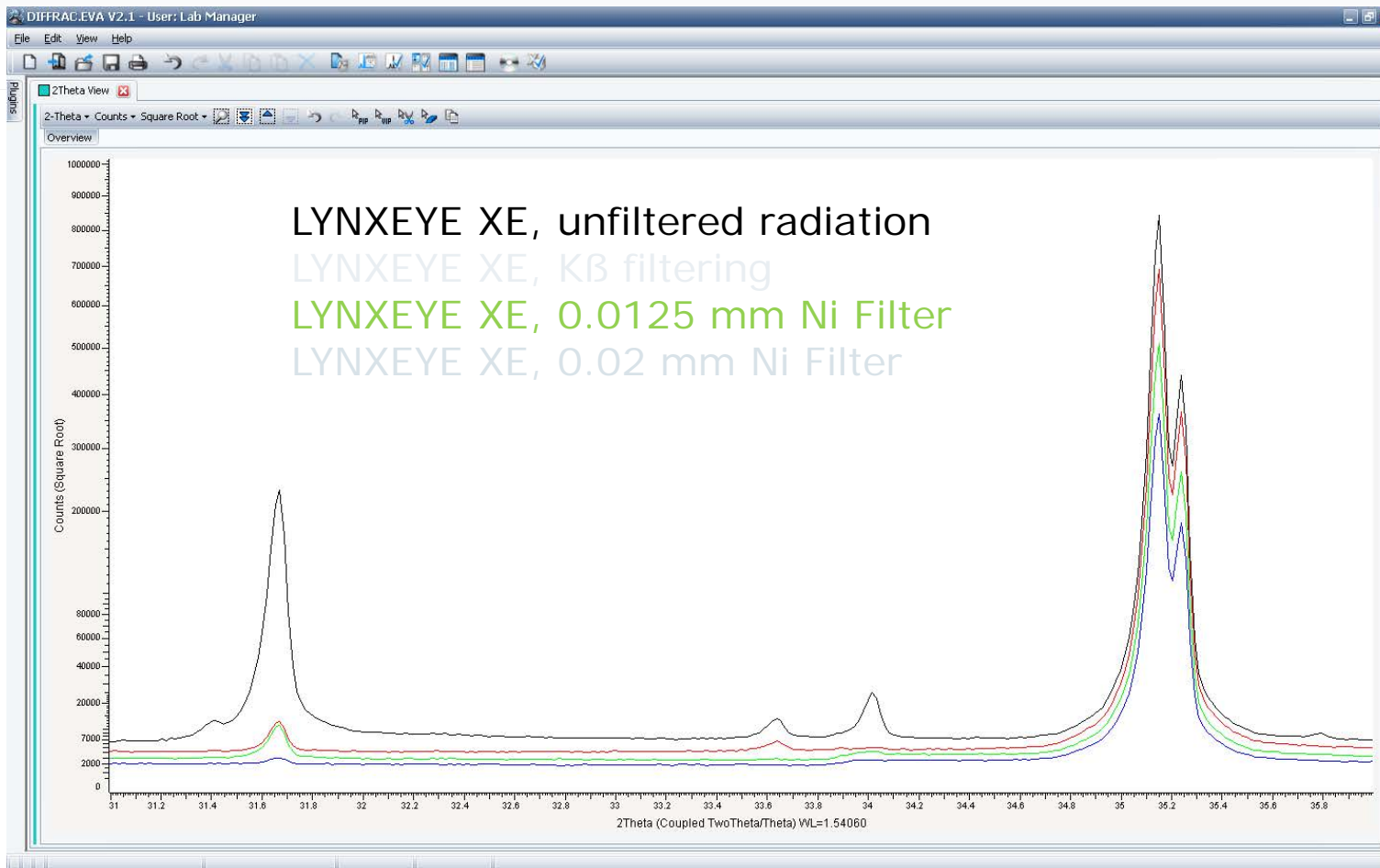


- **Manganese:**
 - Fluorescence filtered completely at <5% loss of peak intensity
- **Iron:**
 - Fluorescence filtered completely at <5% loss of peak intensity
- **Cobalt:**
 - > 90% Fluorescence filtered at <5% loss of peak intensity
 - > 98% Fluorescence filtered at <25% loss of peak intensity
- **Nickel:**
 - > 50% Fluorescence filtered at <5% loss of peak intensity
 - > 90% Fluorescence filtered at about 60% loss of peak intensity using an additional primary Ni filter

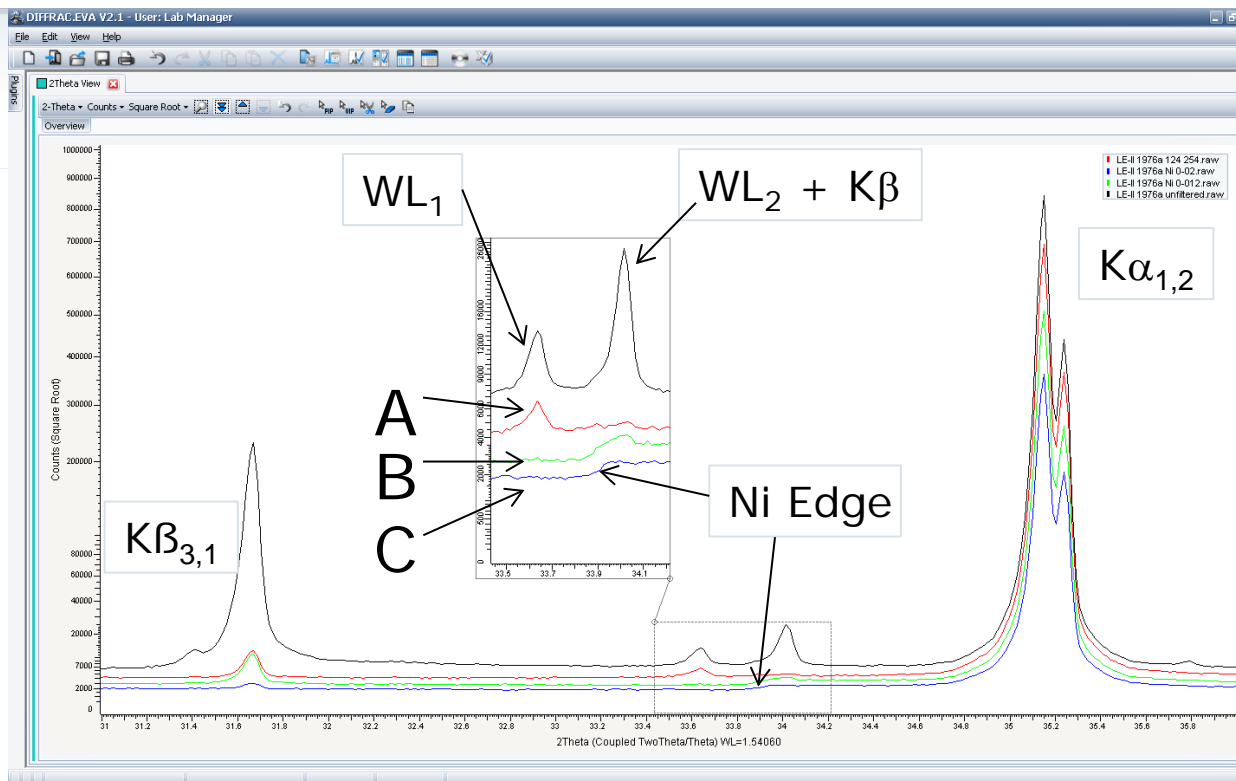
LYNXEYE XE K β filtering NIST SRM 1976a (Corundum)



Square root scale to highlight details

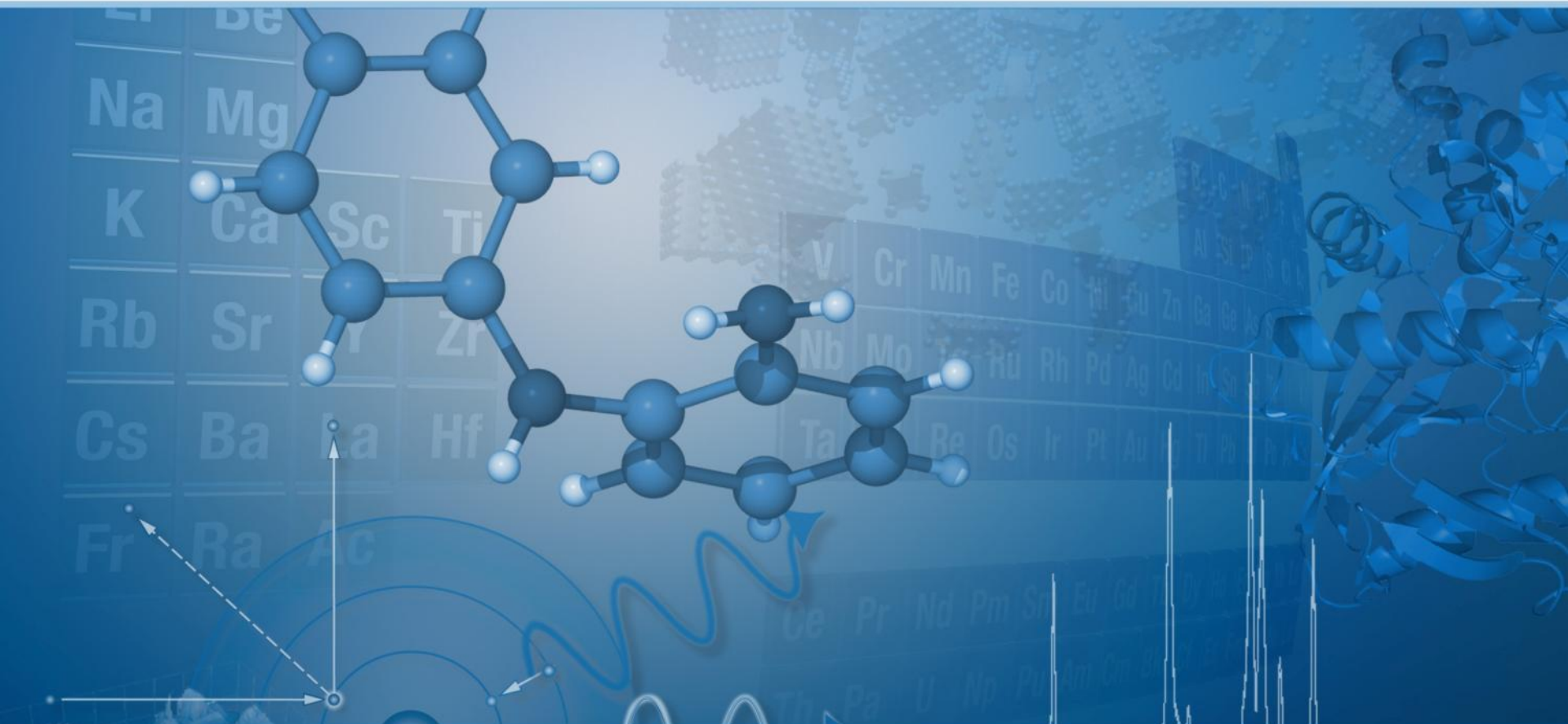


LYNXEYE XE K β filtering NIST SRM 1976a (Corundum)

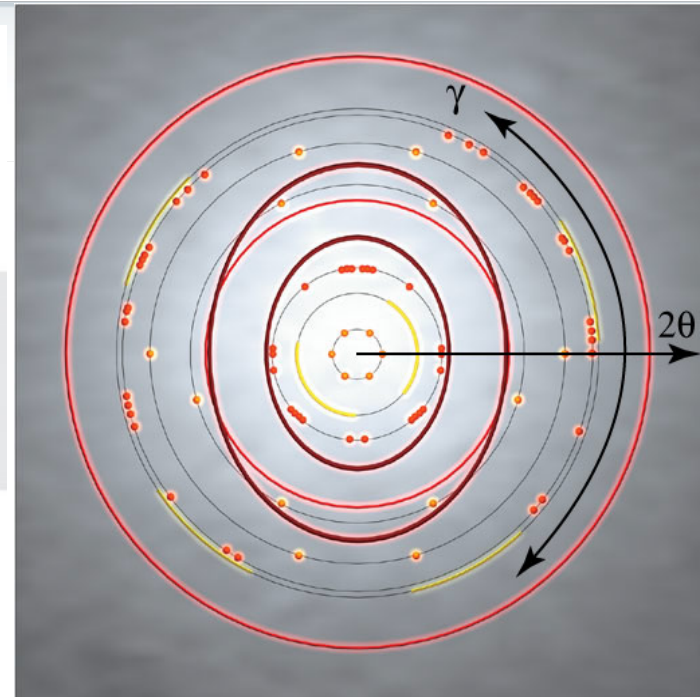
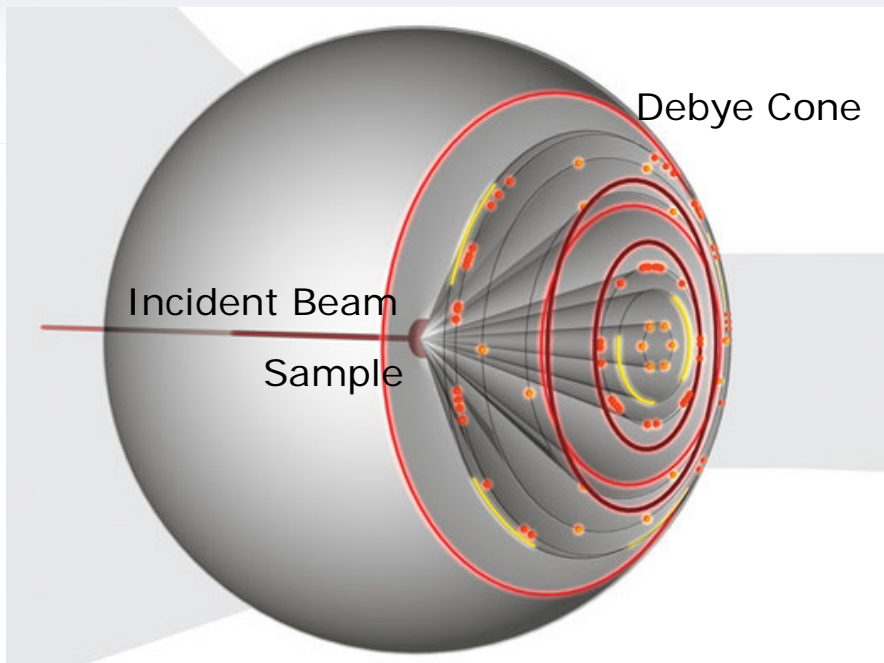


Device	Remnant K β	Intensity loss
A LYNXEYE XE, K β filtering	0.8%	~20%
B LYNXEYE XE, 0.0125 mm Ni Filter	1.2%	~40%
C LYNXEYE XE, 0.02 mm Ni Filter	0.3%	~60%

2D detectors for XRD²



XRD²: Diffraction pattern with both γ and 2θ information

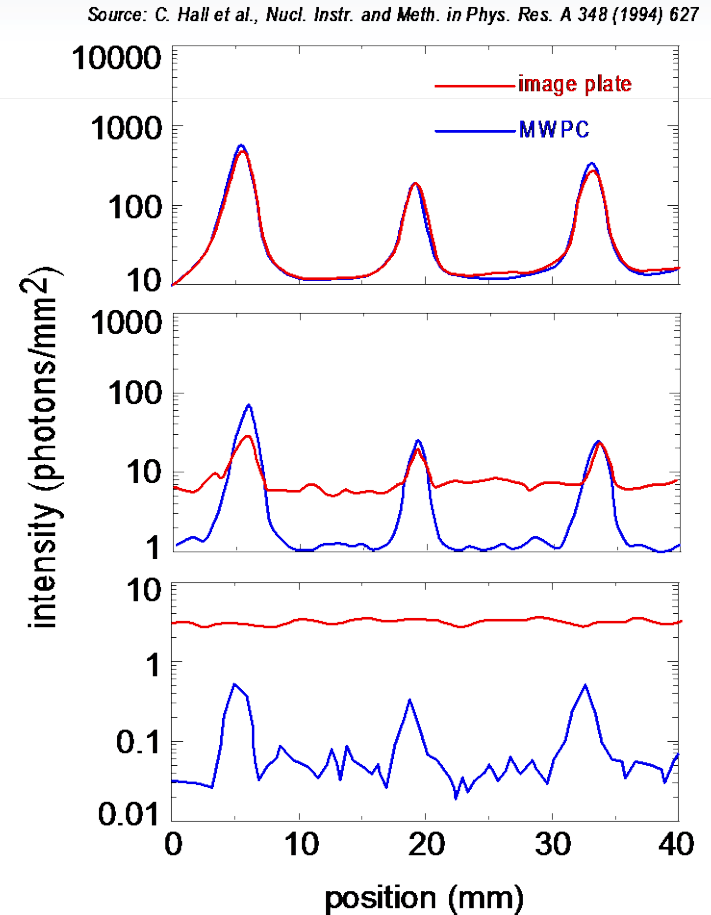
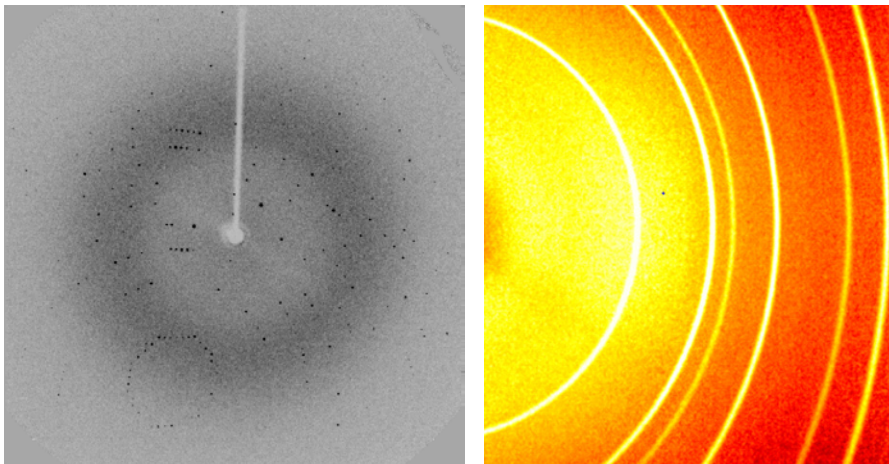


- Integrating over larger γ range improves statistics
 - Especially for microdiffraction, mapping or time resolved measurements
- 2D structure of Debye rings gives additional information
 - Stress, texture, particle size

What is important for XRD²? Photon-counting detector



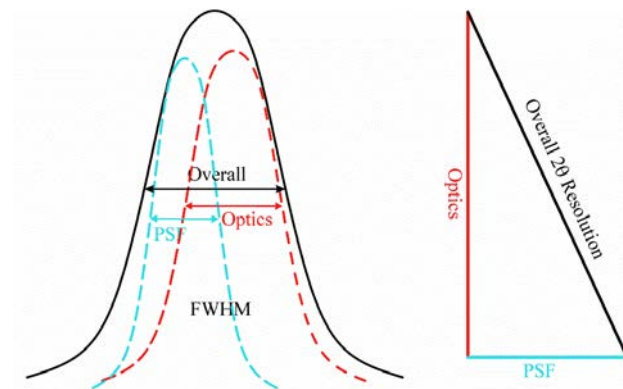
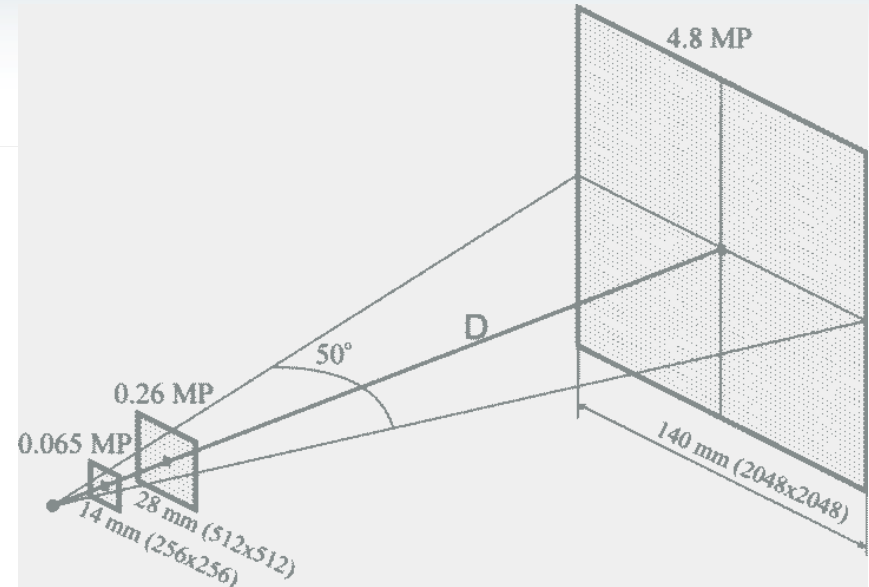
- Photon-counting detectors are preferred
 - In XRD² typically integrate over hundreds or thousands of pixels
 - Detectors with a finite noise background (e.g., CCD, IP) result in lower data quality
 - CCDs and IPs better for crystallography (where reflections span only a few pixels)



What is important for XRD² BIGGER is BETTER



- To cover a given solid angle we may use a big detector **farther away** or a small detector **closer** to the sample
 - E.g., a 140 mm detector at D=150 mm and a 28 mm detector at D=30 mm cover the same solid angle
- For a given angular resolution, a smaller detector requires a smaller beam, this means LESS INTENSITY
 - However, if the 140 mm detector employs a **500 micron beam**, to achieve the same resolution the 28 mm needs to employ a **50 micron beam**
 - ***This results in a 100 times loss in intensity for the small detector!***

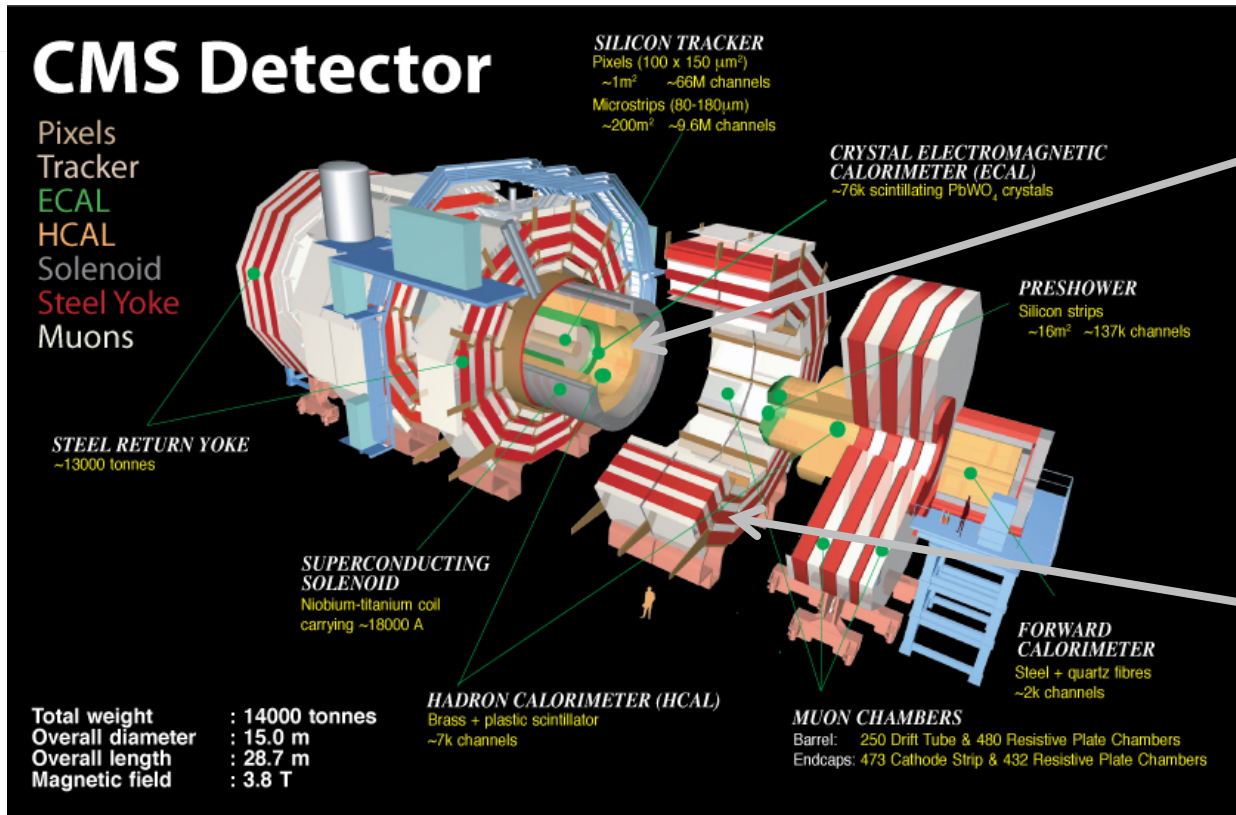


Types of photon-counting area detectors: Gas and Silicon Pixel Array (Si-PADs)



- Photon counting area detectors employ either conversion in gas (usually Xenon) or conversion in a semiconductor (usually Silicon)
 - **Gas detectors:** VANTEC (Bruker), Triton (Rigaku)
 - Advantages
 - Large active areas, no gaps
 - **Lower cost per unit area** ← *Key advantage for lab*
 - Disadvantages
 - Lower count rate capability
 - **Silicon pixel arrays:** Pilatus (Dectris), others in development (e.g., Rigaku HPAD)
 - Advantages
 - **Higher count rate** ← *Key advantage for synchrotron*
 - **Disadvantages**
 - **Higher cost per unit area**

Current generation XRD detectors derived from HEP technology



Inner tracker:
Silicon pixel detectors

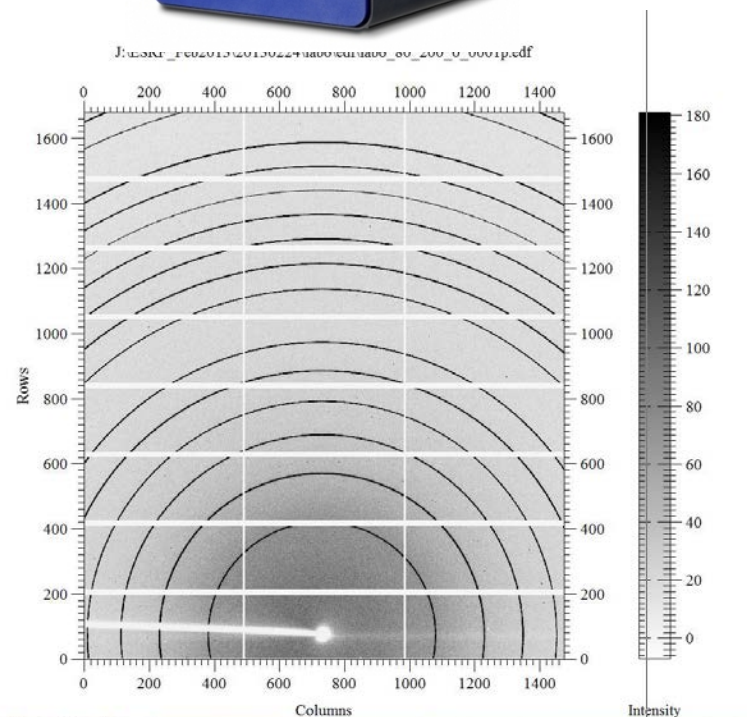


Outer muon chambers:
Gas (RPC) detectors

Silicon Pixel Array Detectors for XRD²



- Silicon Pixel Array detector (Dectris Pilatus 2M) proven to collect very high quality XRD²
 - Uniquely capable of handling the very high flux at 3rd generation beamlines
- However, large Si-PAD arrays are so far less common for home laboratory use because of the relatively high cost

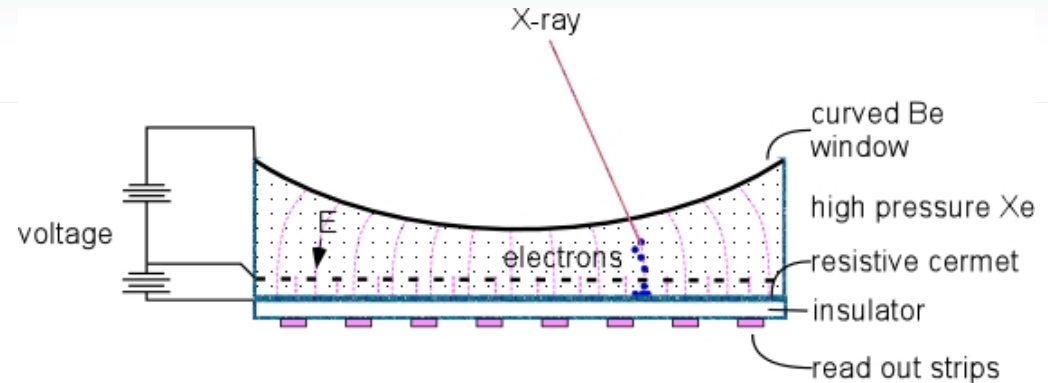


Courtesy P. Pattinson, ESRF

Gas detector principle: Xe microgap detector



- X-rays absorbed in high pressure Xenon
 - Entrance window spherical to minimize parallax
- Electrons drift to amplification grid
 - Electrons undergo Townsend avalanche multiplication
 - Gain $> 10^6$
 - Results in noiseless readout
- Resistive anode protects against discharges (US patent 6340819)
- Readout strips capacitively coupled

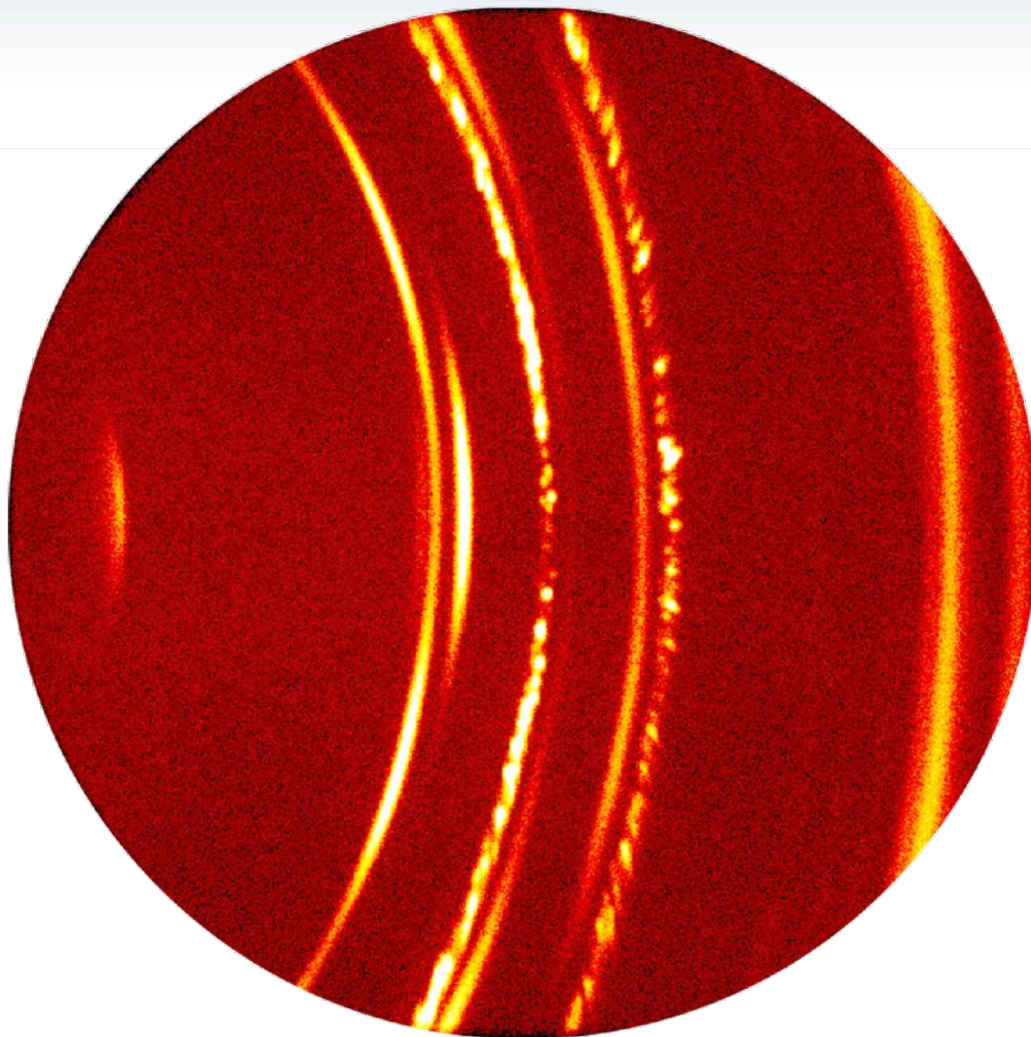


VANTEC-500 – Xe microgap detector



- Large active area: 140 mm in dia.
- Frame size: 2048 x 2048 pixels
- Pixel size: 68 μm x 68 μm
- High sensitivity: 80% DQE for Cu
- No gaps
- Highly uniform response (<1%)
- High max linear count rate: 0.9 Mcps
- Low background noise: 10^{-5} cps/pix
- Maintenance-free: no re-gassing
- Very radiation hard
- Proven reliability: >500 installed worldwide

XRD² data

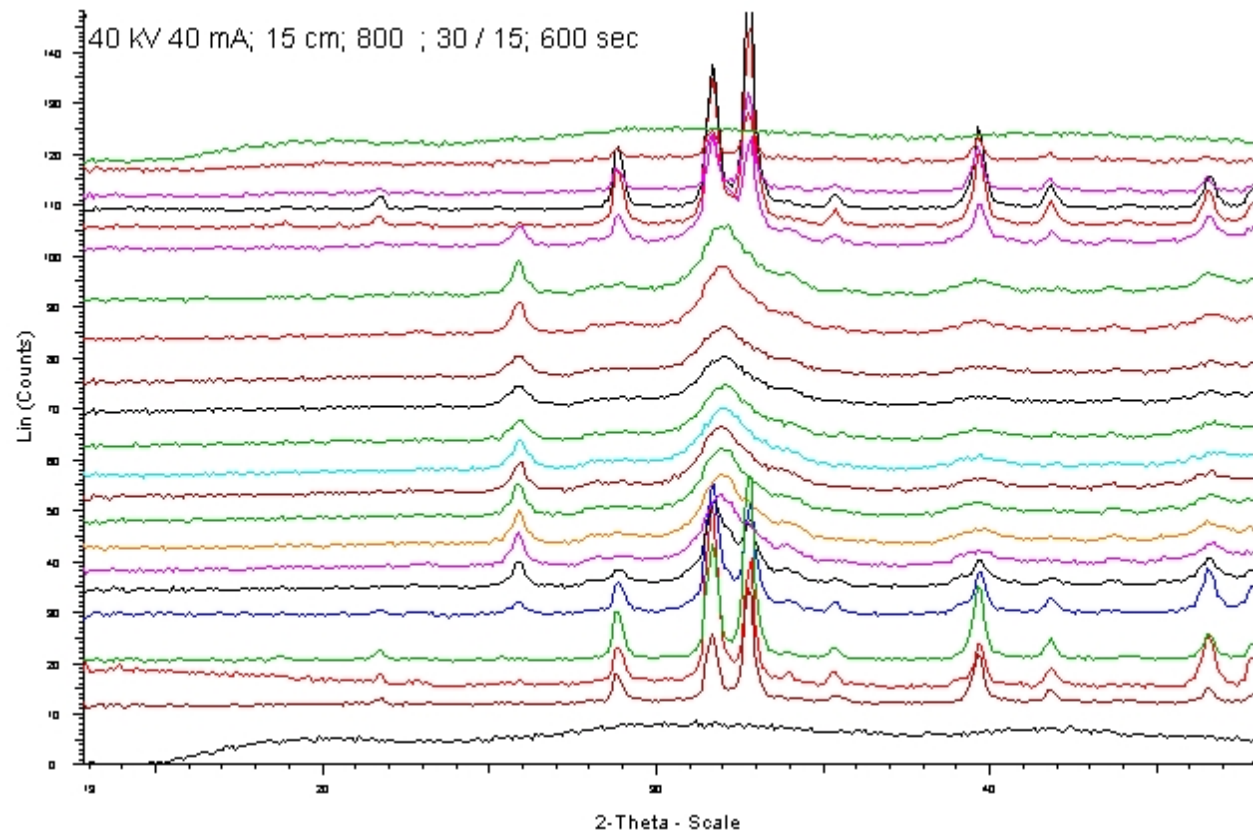


- Multilayer battery anode.
- 2θ coverage: 70° at 8 cm detector distance
- A single frame showing information on phase, stress, texture and grain size

Fast mapping: Scanning Over a Tooth by XRD²

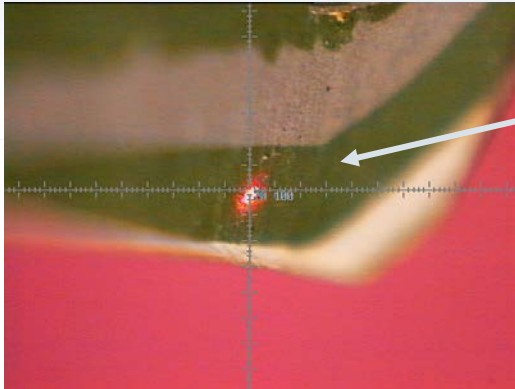


Embedded Tooth
with its Polished
Surface



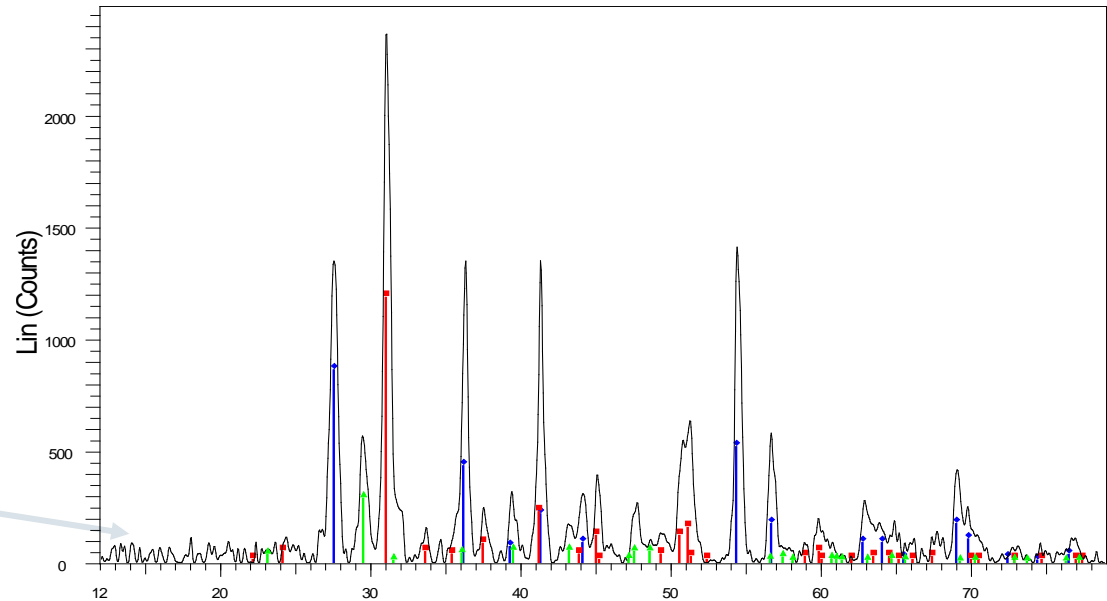
Measurements Taken Vertically, Lengthwise
along the Tooth's Diameter

Microdiffraction: Forensic analysis of car paint



video image (for documentation)

integration of data:
diffractogram for
phase identification



New Frame - File: 2708_07.raw - Start: 11.905 ° - End: 78.926 ° - Step: 0.040 °
◆ 21-1276 (*) - Rutile, syn - TiO₂
▲ 05-0586 (*) - Calcite, syn - CaCO₃
■ 36-0426 (*) - Dolomite - CaMg(CO₃)₂

Conclusions

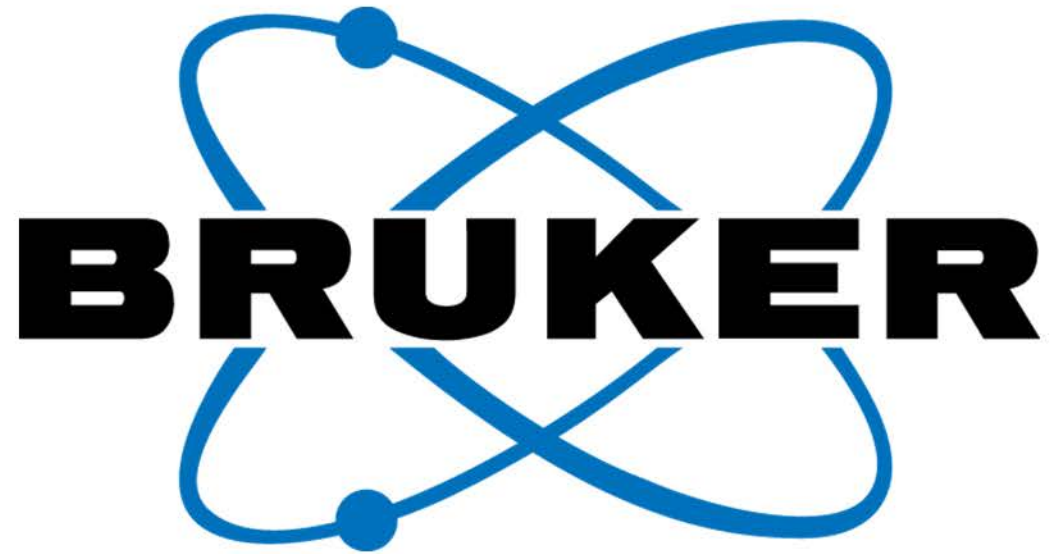


- Energy dispersive detector arrays represents a paradigm change in laboratory X-ray diffraction
 - Highly effective filtering of fluorescence, white radiation and K-beta radiation at greatly reduced intensity losses compared to conventional detectors
 - No absorption edges associated with metal filters
 - Significantly improved intensity, peak-to-background-ratio, lower limits of detection
- XRD² is a powerful technique for a variety of applications including mapping, microdiffraction, stress, texture
- Gas detectors and silicon pixel array detectors both deliver very high quality XRD²
 - For applications with higher count rates silicon detectors are preferred
 - For applications with lower count rates gas detectors deliver comparable data



Acknowledgments

- LynxEye XE
 - W. Dabrowski, T. Fiutowski, P. Wiacek, University of Science and Technology, Krakow
 - J. Fink, H.G. Krane, Bruker AXS
- VANTEC 500
 - B. Becker, G. Wachter, S. Medved, Bruker AXS



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